The 2024 International Workshop on the High Energy Circular Electron Positron Collider

https://indico.ihep.ac.cn/event/22089/sessions/14186/#20241025

Measuring QED to 10^{-4} with radiative Bhabha for precision, for e^+e^- collision luminosity



Physics goal at CEPC



Bhabha generators for MC study

- BHLUMI 4.04
 S. Jadach [CPC 101 (1997) 229]
- ReneSANCe 1.0.0
 R.Sadykov [CPC 256 (2020) 107445]

"Compariing Event Generator.." poster by J.Gong, this workshop

BHLUMI for LEP luminosity

Framework of YFS exponentiation



BHLUMI 4.04

S. Jadach [CPC 101 (1997) 229]

2000 systematic 0.054%

[NPB 547 (1999) 39] [PLB 459 (1999) 649] [OPAL Z⁰ lineshape, EPJC 14, 373] **2020 systematic 0.037%** [PLB 803 (2020) 135319]



LEP theoretical uncertainties [EPJC 81 (2021) 1047]

Type of correction/error	Update 2019
(a) Photonic $\mathcal{O}(L_e \alpha^2)$	0.027% [8]
(b) Photonic $\mathcal{O}(L_e^3 \alpha^3)$	0.015% [9]
(c) Vacuum polariz.	0.009% [7,10]
(d) Light pairs	0.010% [7]
(e) Z and s-channel γ exchange	0.015% [11, 12]
(f) Up-down interference	0.0014% [13]
(g) Technical Precision	(0.027)%
Total	0.037%



BHLUMI $e^+e^- \rightarrow e^+e^-(n\gamma)$



BHLUMI $e^+e^- \rightarrow e^+e^-(n\gamma)$ at CEPC

BHLUMI demo.f cuts

- ACC 0 CMS 10 mRad < $\theta(e^{\pm})$ < 80 mRad
- ACC 1 .and. s'(P2,Q2)/s(P1,Q1) >0.5

Beam crossing, 33 mRad

→ Boost in x direct e⁺, e⁻ offset by 33 mRad

10 M events generated for 10 - 80 mRad, $\theta(e^{\pm})$ distributed from 7 mRad ACC0 = 47.9 %

ACC1 = 45.9 %

θ(e[±]) shown
for CMS
and boosted
of all generated





events with 0 photos Show δ back-back distribution

BHLUMI $e^+e^- \rightarrow e^+e^-(n\gamma)$ at CEPC



o 91% with $\Omega(e^{\pm},\gamma) < 5$ mRad

LumiCal acceptance:

- \circ |y|>12 mm at LYSO front face $\pm z=647$ mm
- $\circ~$ boosted e^\pm and γ selection applied
- $\circ~$ Correlation of E(e[±]) and E(γ)
- $\circ~$ ISR vs FSR, by opening angle $\Omega(e^{\pm}\!,\!\gamma)~$ to P2,Q2





Acceptance for $e^+e^- \rightarrow e^+e^-(n\gamma)$ at CEPC

Bhabha events in LumiCal acceptance

e⁺,e⁻,γ: |y|>12 mm at LYSO front face ±z=647mm

±z Hemispheres	BHLUMI generated	& P2,Q2 y >12mm
e⁺	60.3 %	3.87 %
e [±] γ	39.7 %*	3.16 %

*ISR 20.3%, FSR 19.4%

Detectable Bhabha, e⁺,e⁻,γ: |y|>12 mm

±z Hemispheres	P2,Q2 y >12mm	& E(γ)>0.1GeV y(γ) >12mm
e⁺	55.1%	14.7 %
$e^\pm \gamma$	44.9 %	ISR 0.89 % FSR 13.8 % FSR 2.96%*

*FSR $\Omega(e^{\pm},\gamma) > 5 \text{ mRad}$





Radiative Bhabha measurements



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LumiCal acceptance, racetrack beampipe



LumiCal acceptance at |z|=1000mm, with RaceTrack pipe r=10mm

ONE <i>e</i> ⁺ or <i>e</i> ⁻ detected		e ⁺ , e ⁻ back-to-back detected	
θ>25 mRad	θ>25mR & y >25mm	θ>25 mRad	θ>25mR & y >25mm
133.5 nb	81.8 nb	85.4 nb	78.0 nb

Precision for Bhabha event counting to 10-4 ¹⁰

Luminosity \mathcal{L} is derived by

 $e^+e^- \rightarrow e^+e^-(n\gamma)$

$$\mathcal{L} = \frac{1}{\varepsilon} \frac{N_{\text{acc}}}{\sigma^{\text{vis}}} \quad \sigma = \frac{16\pi\alpha^2}{s} \left(\frac{1}{\theta_{\min}^2} - \frac{1}{\theta_{\max}^2} \right)$$

Bhabha detected for

- a pair of back-back electrons,
- precision ϑ of $e, e(\gamma)$ in fiducial region

 $\delta L/L \sim 2 \delta \vartheta / \vartheta_{min}$

 $\delta L/L = 10^{-4}$

at $z = \pm 1000 \text{ mm}$, $\vartheta_{min} = 20 \text{ mRad}$ $\rightarrow \delta \vartheta = 1 \mu Rad$, or $dr = 1 \mu m$

error due to offset on Z

$$\rightarrow$$
 50 μ m on Z eq. dr = $\delta z \times \vartheta = 1 \mu$ m

Luminosity systematics due to event counting in/out fiducial edge \rightarrow offset on the mean of θ_{min}

50 GeV electron shower on diamond

- 50 GeV electrons at CMS 10 mRad, boosted in Lab 26.5 mRad
- GEANT shower in **3 mm thick Cu beampipe (~300 mm traversing)**
- Measuring dE/step of **charged tracks** (>100 keV) **in diamond**

3mm Cu pipe, @26.5 mRad ch. Multiplicity Cu+diamond = 620 Shower spread in z: σ_z = 30 mm

Electron shower spread in θ on diamond

- Shoot 50 GeV electrons at CMS 9 ~ 12 mRad, Lab 25.5 ~ 28.5 mRad \bigcirc
- dE/step deposits of charged tracks (>100keV) in diamond Ο

dE/steps in z profile

y (mm)

Survey/monitoring, for Beam IP position

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Smearing @ IP position of BHLUMI

- bunch size $\sigma_x = 6 \mu m$, $\sigma_z = 9 mm$ • IP spot, 33mRad Xing $\sigma_x = 6 \mu m$, $\sigma_z = 380 \mu m$
- $Z \rightarrow e^+, e^-$ at $\vartheta = 30 \, mRad$ smearing at @z=560mm smeared width $\sigma(\vartheta) = 24 \, \mu Rad$ back-to-back $\sigma(\Omega) = 21 \, \mu Rad$

e⁺, e[−] back-back

CEPC LumiCal design

Bellow

Bellow

 $= 17.4 X_0$

GEANT LumiCal electron shower

Front 2X₀ LYSO, on radiative e,γ

Bhabha hits on LYSO, |y|>12mm

Incident particles are e^{\pm} ,(γ)

- GEANT sum dE/dx in each LYSO bars 3x3mm², 23 mm long, 2X₀
- **Deviation to e**^{\pm} **truth** (impact hit >E_b/2) mostly < 0.2mm
- **Hit distributions in a Bar** distributed due to Bhabha θ, w./w.o. photon

Electron hits on 1st Si-wafer IP $(\sigma_x, \sigma_z) = (6, 380 \, \mu m)$

50 GeV e^+ , e^- @ ($\vartheta = \pm 30$ mRad, $\varphi = 1.0$, 1.0+ π Rad) Si wafer @z=560mm $\circ |\mathbf{x}| < 6.0 \text{ mm } \sigma(\vartheta) = 54 \ \mu \text{R}$ (1mm Be)

 $\circ |x| > 6.0 \text{ mm } \sigma(\vartheta) = 95 \mu R$ (1m Al pipe) ο back-back Op.Ang $\sigma(\Omega) = 137 \mu R$

NJU GEANT4 validation, test-beam preparation

Be(1mm): $\sigma(\vartheta) = 30 \,\mu\text{R}$ Be(2mm): $\sigma(\vartheta) = 50 \,\mu\text{R}$

→ GEANT tracking steering, testbeam confirmation

1 mm Be thin pipe window 33mm = 0.09X₀ traversing @ 30mR

multiple scattering, against 10⁻⁴

- **1. BHLUMI** scattered e^+ , e^- **Multi. Scatt. smearing 100 µRad** $\theta' = \theta \cdot \sigma (100\mu R), \quad \varphi' = \varphi \cdot \sigma (100\mu R)$
- 2. $\delta N/N$ due to $\sigma(100\mu R)$ smearing δN = deviation due to Multi.Scatt. effect is Gaussian, Symmetric at θ_{min} = 25 mRad, slope of Bbhabha in neiboring 100 μ Rad bins to 25mR $\delta N(@25mR)/N(25-80 mR) < 10^{-4}$

Bhabha electrons, θ deviated by radiative photon measuring e,γ vs QED predictions and cross section

- \circ Si-det on electron θ , multi.scatt. ~50 μ Rad
- \circ ISR/FSR of e, γ in LYSO, 3x3 mm² segmentation

Beam line, IP measurement

slow control & monitoring on beam x,y positions

- $\circ~1~\mu m$ precision on single beam position
- e⁺,e⁻ beam line crossing → IP position,
 x,y, and z by beam-crossing, with the means better than 1 μm

Test beams preparation for

- Multiple scattering by ~1° of 1mm thick Be
- o Electron shower sampling, in CEPC MDI configuration